Electronic Patent Application Fee Transmittal								
Application Number:	10	10519699						
Filing Date:	14	14-Sep-2005						
Title of Invention:		Ion implantation device and a method of semiconductor manufacturing by the implantation of boron hydride cluster ions						
First Named Inventor/Applicant Name:	Th	Thomas N. Horsky						
Filer:	Jol	John S. Paniaguas/Michael Tomsa						
Attorney Docket Number:	21	211843-00032						
Filed as Large Entity								
U.S. National Stage under 35 USC 371 F	iling	Fees						
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)			
Basic Filing:				,				
Pages:								
Claims:								
Miscellaneous-Filing:								
Petition:								
Patent-Appeals-and-Interference:								
Post-Allowance-and-Post-Issuance:								
Extension-of-Time:								

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Submission- Information Disclosure Stmt	1806	1	180	180
	Tota	180		